

Docket No.: 285995US26PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION: Kohei KAWAMURA, et al.

SERIAL NO.: 10/567,733

GAU: 2823

FILED: February 10, 2006

EXAMINER: Kevin a. PAREDO

FOR: METHOD FOR FORMING FILM, METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE, SEMICONDUCTOR DEVICE AND SUBSTRATE
TREATMENT SYSTEM

LETTER SUBMITTING REPLACEMENT DRAWING SHEET(S)

COMMISSIONER FOR PATENTS
Alexandria, VA 22313

SIR:

Responsive to the below indicated communication, the following drawing sheet is submitted herewith:

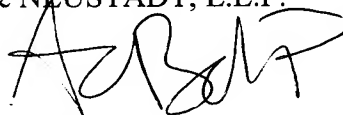
- ☒ 1 Replacement Drawing Sheet ☐ _____ New Drawing Sheets
☐ _____ Annotated Drawing Sheets
- ☒ Official Action dated April 8, 2009
☐ Notice of Allowance/Issue Fee dated _____
☐ Other dated _____

The changes and/or modifications made include the following:

FIG. 1 is labeled "PRIOR ART."

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, L.L.P.



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